

61 IN THE UNITED STATES PATENT AND TRADEMARK OFFICE AF/1733

Applicant: Edward A. Schrock et al.

Title: METHOD FOR ATTACHING A SEMICONDUCTOR DIE TO A SUBSTRATE

Docket No.: 2003.527US2

Serial No.: 09/649827

Filed: August 29, 2000

Due Date: February 16, 2004

Examiner: Geoffrey L Knable

Group Art Unit: 1733

**MS AF**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

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**FEB 23 2004**

We are transmitting herewith the following attached items (as indicated with an "X"):

☒ A return postcard.

☒ An Amendment and Response under 37 CFR 1.116 (10 Pages).

Please consider this a **PETITION FOR EXTENSION OF TIME** for sufficient number of months to enter these papers and please charge any additional fees or credit overpayment to Deposit Account No. 19-0743.

SCHWEGMAN, LUNDBERG, WOESSNER & KLUTH, P.A.

Customer Number 21186

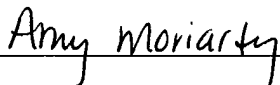
By: 

Atty: Suneel Arora

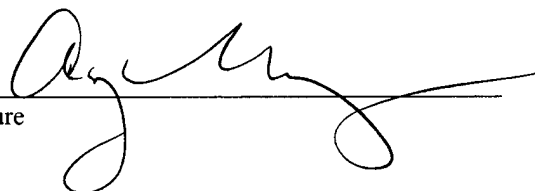
Reg. No. 42,267

CERTIFICATE UNDER 37 CFR 1.8: The undersigned hereby certifies that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail, in an envelope addressed to: MS AF, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on this 12th day of February, 2004.

Name

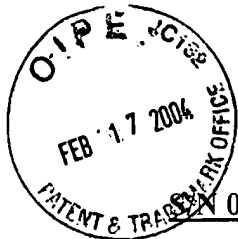


Signature



SCHWEGMAN, LUNDBERG, WOESSNER & KLUTH, P.A.

(GENERAL)



**EXPEDITED PROCEDURE – EXAMINING GROUP 1733**

**09/649827**

**PATENT**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant:	Edward A. Schrock et al.	Examiner:	Geoffrey L Knable
Serial No.:	09/649827	Group Art Unit:	1733
Filed:	August 29, 2000	Docket No.:	303.527US2
Title:	METHOD FOR ATTACHING A SEMICONDUCTOR DIE TO A SUBSTRATE		

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**AMENDMENT & RESPONSE UNDER 37 C.F.R. 1.116**

Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
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In response to the Final Office Action mailed December 16, 2003, please amend the application as follows: